

NACEF MOUNA/génie des procédés/Semestre 5/TP Chimie Physique 1/Section_L3								
Matricule	Note	Absent	Absence Justifiée	Observation	Section	Groupe		
212136037862	12.5					Section_L3/Groupe_L3		
191936035377	13.0					Section_L3/Groupe_L3		
212136039869	13.0					Section_L3/Groupe_L3		
212136039550	14.0					Section_L3/Groupe_L3		
212136042360	10.0					Section_L3/Groupe_L3		
2399646960	16.25					Section_L3/Groupe_L3		
212136036983	10.0					Section_L3/Groupe_L3		
212136042533	12.75					Section_L3/Groupe_L3		
212136039669	13.5					Section_L3/Groupe_L3		
212136037010	13.0					Section_L3/Groupe_L3		
212136037205	13.75					Section_L3/Groupe_L3		
212136035383	12.75					Section_L3/Groupe_L3		
181936041351	16.5					Section_L3/Groupe_L3		
212136039580	13.25					Section_L3/Groupe_L3		
212136037647	10.75					Section_L3/Groupe_L3		
2389471001	10.5					Section_L3/Groupe_L3		
191936035367	15.5					Section_L3/Groupe_L3		
2301649025	0.0					Section_L3/Groupe_L3		
212136036474	18.5					Section_L3/Groupe_L3		
212136037200	12.5					Section_L3/Groupe_L3		
212136038429	15.75					Section_L3/Groupe_L3		
212136035064	13.25					Section_L3/Groupe_L3		
212136035997	12.25					Section_L3/Groupe_L3		
212136038823	10.0					Section_L3/Groupe_L3		
212136037810	10.5					Section_L3/Groupe_L3		
212136036356	13.25					Section_L3/Groupe_L3		
212136002066	15.75					Section_L3/Groupe_L3		
212136035404	13.0					Section_L3/Groupe_L3		
191936037150	10.0					Section_L3/Groupe_L3		
212136035379	11.75					Section_L3/Groupe_L3		
212136035380	12.5					Section_L3/Groupe_L3		













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